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Docket No.: R2180.0193/P193  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Naohiro Ueda

Application No.: 10/801,838

Confirmation No.: 3147

Filed: March 17, 2004

Art Unit: 2814

For: SEMICONDUCTOR APPARATUS AND  
METHOD OF MANUFACTURING THE  
SAME

Examiner: A. Kalam

DO NOT ENTER: /AK/

06/27/2008

**AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116**

**MS AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated April 14, 2008, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 6 of this paper.